



- REPLACEMENT SHEET -

Inventor: Soo Young Choi et al.
Serial No.: 10/829,016
Title: Controlling the Properties and Uniformity ...
Docket No.: AM-9230 Page 1 of 5
Phone: S. L. Church (650) 473-9700

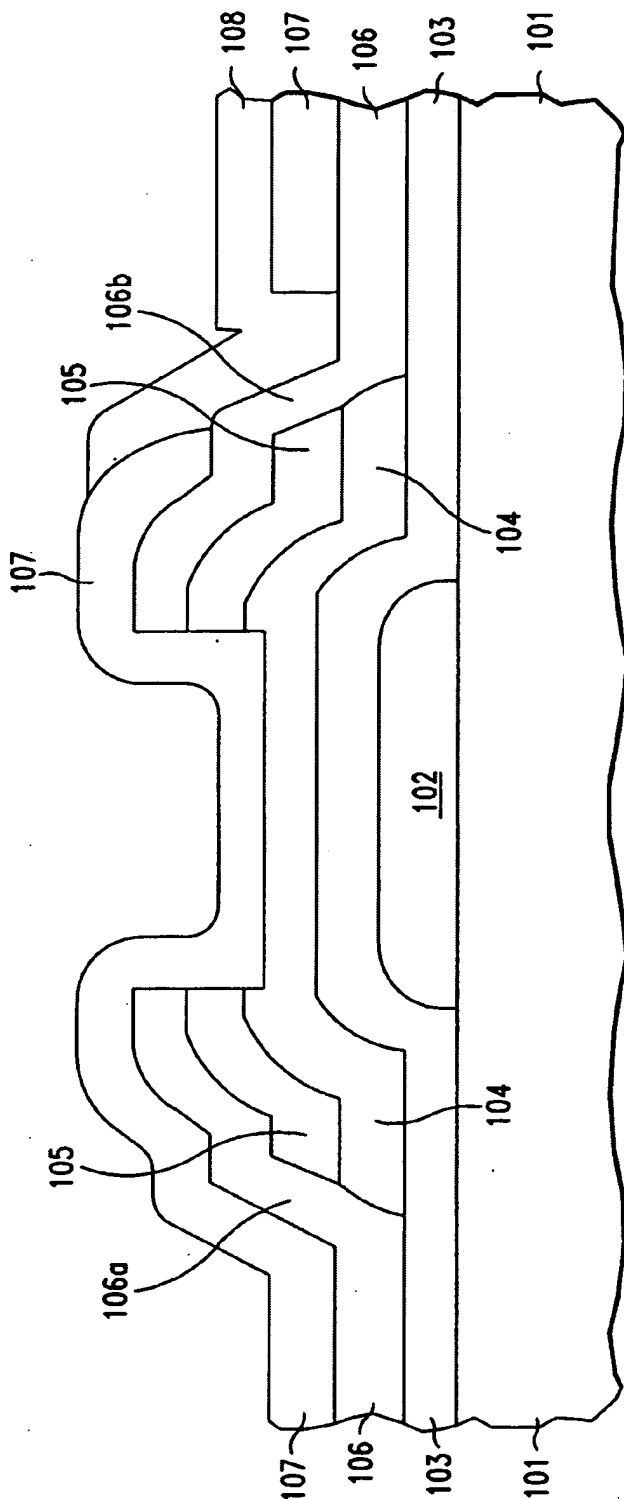


FIG. 1A (PRIOR ART)

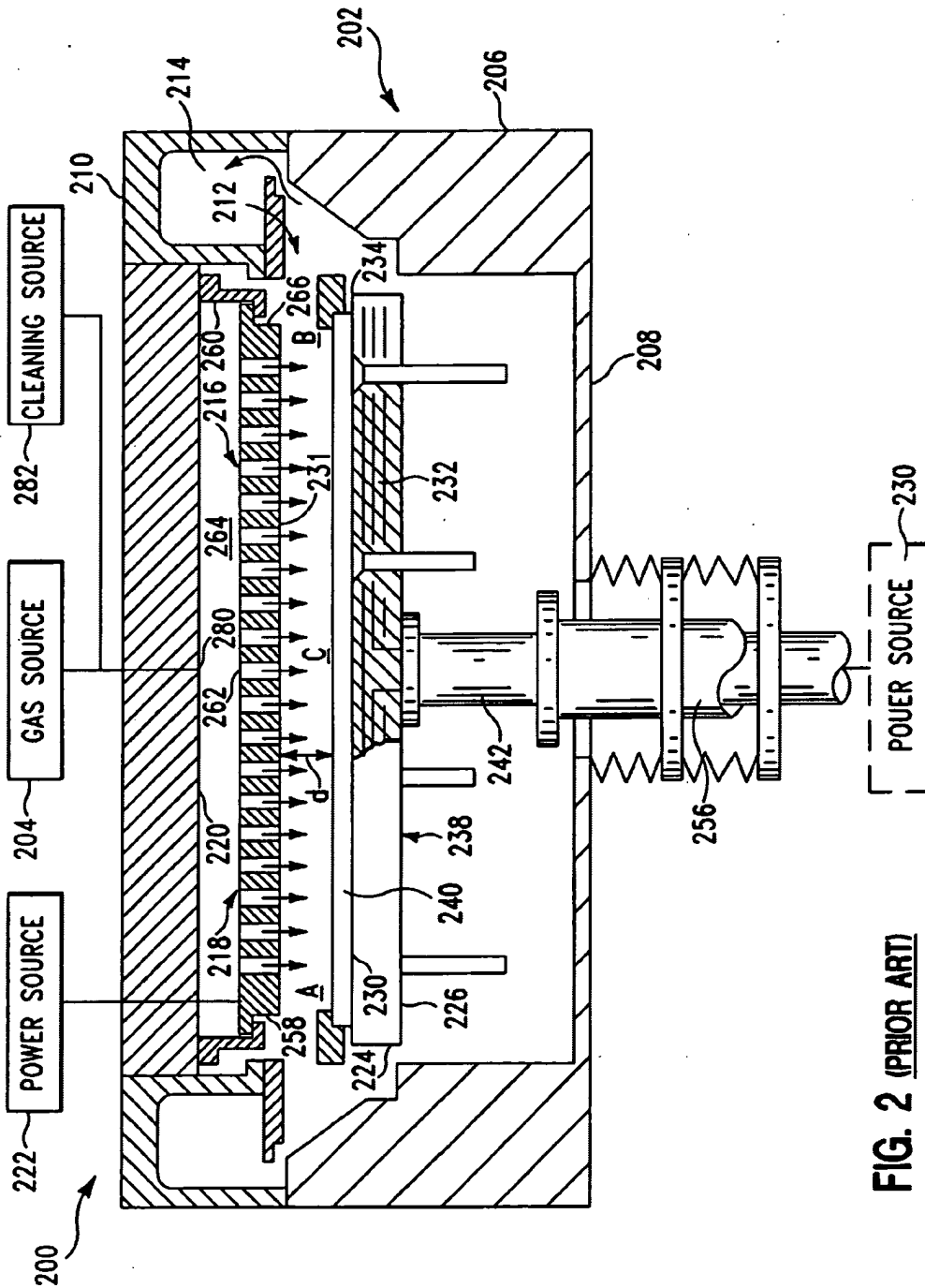


FIG. 2 (PRIOR ART)



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- ITO Pattern(MASK5)
- ITO Sputtering
- Passivation Etch(MASK4)
- SINx PECVD
- n+ a-Si Etch-Back
- S/D Pattern(MASK3)
- S/D Sputtering
- a-Si Pattern(MASK2)
- n+a-Si/a-Si/SINx PECVD
- Gate Pattern(MASK1)
- Gate Metal Sputtering

300

FIG. 3A

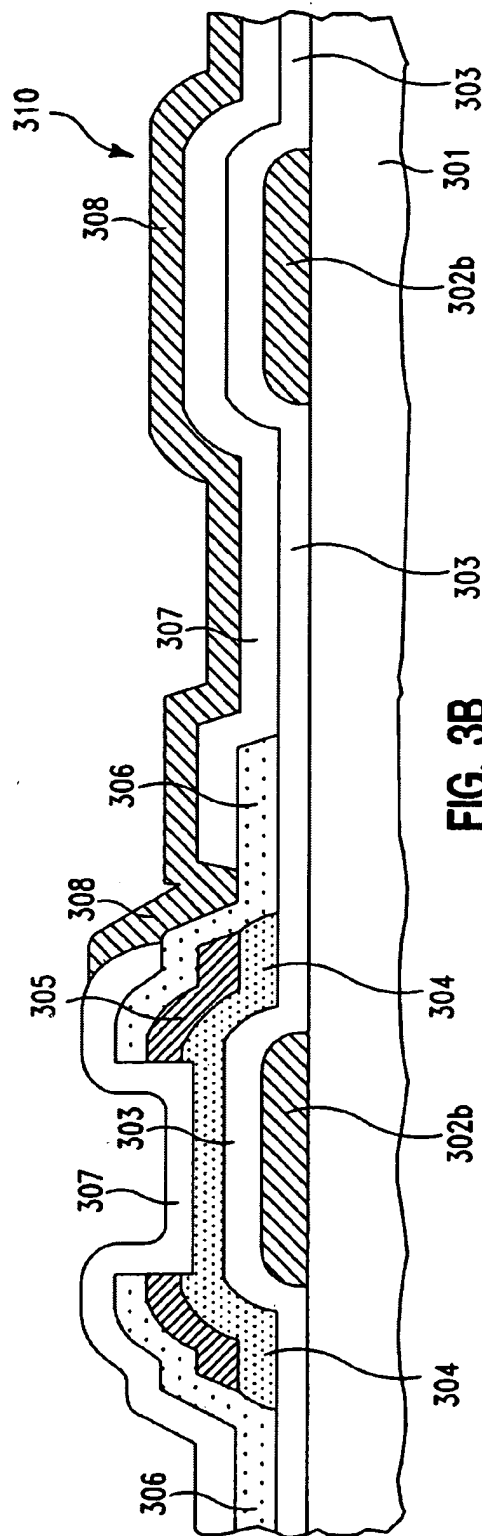
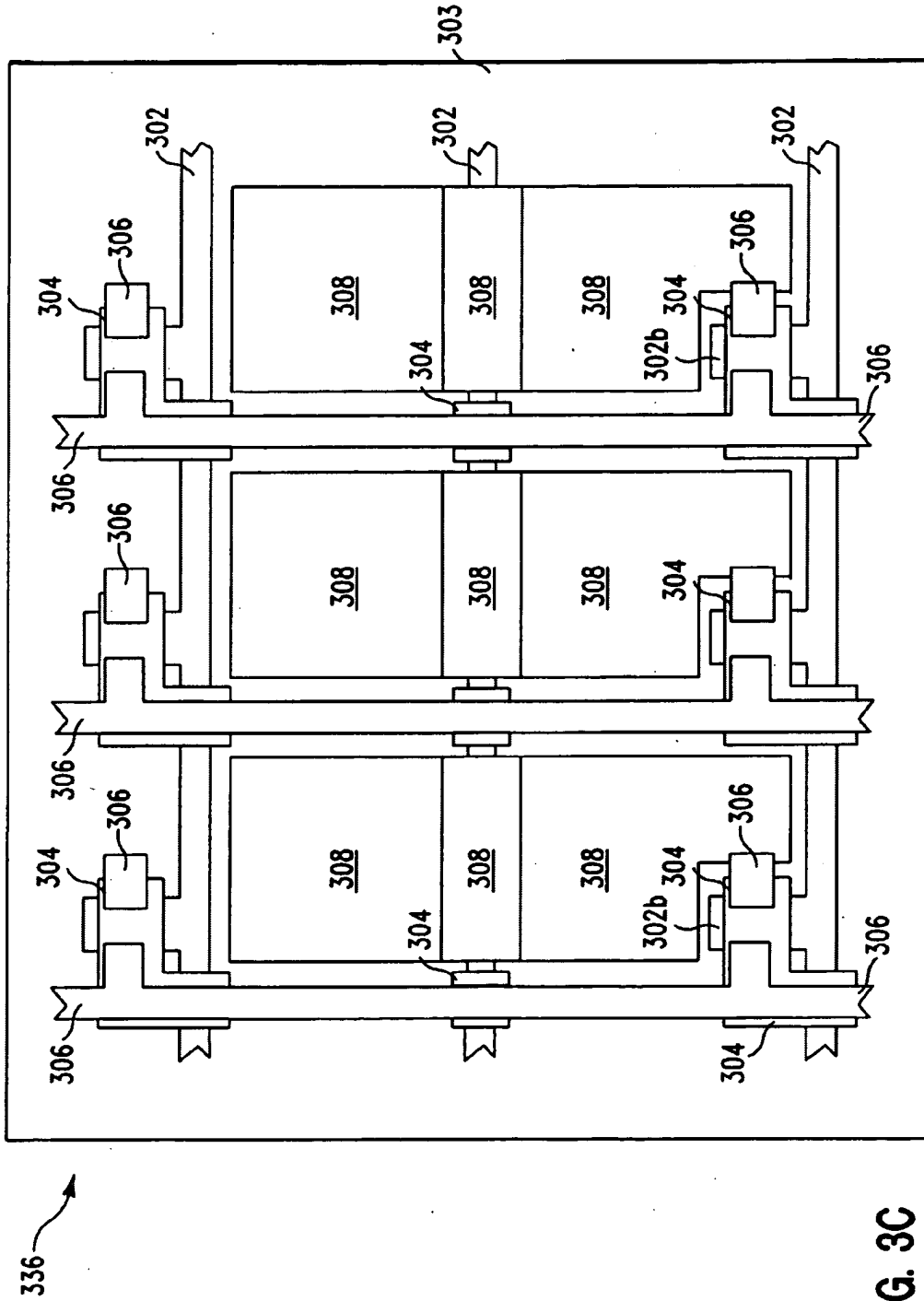


FIG. 3B

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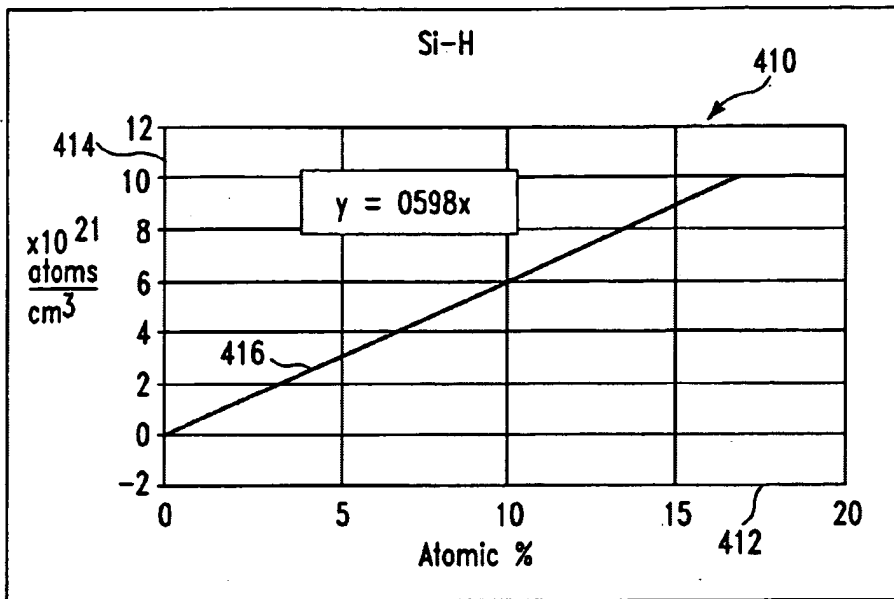


FIG. 4A

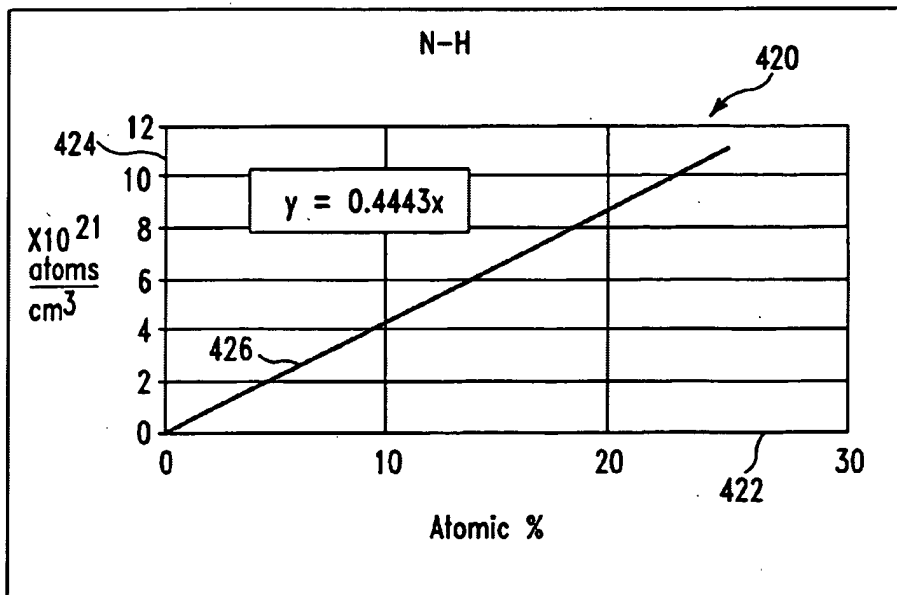


FIG. 4B